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December 31, 2001

Date

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Present Application

Applicants : Chee Peng Neo, Cher Khng Victor Tan, Kian Seng Ho and Hock Chuan Tan

Application No. : 09/944,247 Confirmation No.: 1800

Filed : August 30, 2001

For : METHOD AND APPARATUS FOR DETECTING TOPOGRAPHICAL FEATURES OF MICROELECTRONIC SUBSTRATES

Docket No. : 108298548US

Date : December 31, 2001

Foreign Application

Application No. : 200104881-8

Country : Singapore

Filed : August 13, 2001

Commissioner for Patents
Washington, DC 20231

PRELIMINARY AMENDMENT

Dear Commissioner:

Please amend the application as follows and consider the application in light of the following remarks.